## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Morito AKIYAMA et al.

Atty. Ref.: 1035-548; Confirmation No. NONE

Appl. No. to be assigned (U.S. National Phase of PCT/JP03/06796 filed 29 May 2003)

TC/A.U. to be assigned

Filed: herewith

Examiner: to be assigned

For: PIEZOELECTRIC ELEMENT BASED ON SUPERHIGH-ORIENTED ALUMINUM

NITRIDE THIN FILM AND MANUFACTURING METHOD THEREOF

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November 30, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## PRELIMINARY AMENDMENT

In order to place the above-identified application in better condition for examination, please amend the application as follows: